

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Zhu et al.

Attorney Docket No.:

NOVLP090/NVLS-002888

Application No.: 10/733,858

Examiner: Not yet assigned

Filad: December 10, 2003

Group: 2812

Title: BIASED H2 ETCH PROCESS IN

DEPOSTION-ETCH-DEPOSITION GAP

Confirmation No. 7860

FILL

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on April 5, 2005 in an envelope addressed to the commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313 450.

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT 37 CFR §§1.56 AND 1.97(b)

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The references listed in the attached PTO Form 1449, may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these references of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is: (i) filed within three (3) months of the filing date of the above-referenced application, (ii) believed to be filed before the mailing date of a first Office Action on the merits, or (iii) believed to be filed before the mailing of a first Office Action after the filing of a Request for Continued Examination under §1.114. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. NOVLP090).

Respectfully submitted,

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stration No. 39,489

Atty Docket No. Application No.:
NOVLP090/NVLS-2888 10/733,858

Information Disclosure
Statement By Applicant

(Use Several Sheets if Necessary)

Atty Docket No. Application No.:
NOVLP090/NVLS-2888 10/733,858

Applicant:
Zhu et al.
Filing Date
December 10, 2003 2812

U.S. Patent Documents

Examiner	-			Documents		Sub-	Filing
Initial	No.	Patent No.	Date	Patentee	Class	class	Date
	A1	6,030,881	02/29/00	Papasouliotis			
	A2	6,265,269	07/24/01	Chen et al.			
	A3	6,277,764	08/21/01	Shin et al.			
	A4	6,335,261	01/01/02	Natzle, et al.			
	A5	6,479,396	11/12/02	Xu et al.			
	A6	6,569,777	05/27/03	Hsu et al.			
	A7	2001-0019903	09/06/01	Shufflebotham et al.			
	A8	2004-0058549	03/25/04	Cai, Yuqi et al.			
	A9	6,867,086	03/15/05	Chen et al.			
	A10	6,531,377	03/11/03	Knorr et al.			
	A11	5,516,729	05/14/96	Dawson et al.			
	A12	6,566,229	05/20/03	Hong et al.			
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	A14	6,479,361	11/12/02	Park			
	A15	6,642,105	11/04/03	Kim et al.			,
	A16	2003-0087506	05/08/03	Kirchhoff			
	A17	6,596,654	06/22/03	Bayman et al.			

Foreign Patent or Published Foreign Patent Application

Examiner		Document	Publication	Country or		Sub-	- Translation	
Initial	No.	No.	Date	Patent Office	Class	class	Yes	No

Other Documents

<u> </u>					
Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication			
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Examiner		Date Considered			
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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.